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PATENT

TED STATES PATENT AND TRADEMARK OFFICE

Examiner	:	J. Diaz
For	:	CHEMICAL MECHANICAL PLANARIZATION OF CONDUCTIVE MATERIAL
Filed	:	April 19, 2000
Appl. No.	:	09/552,383
Applicant	:	Stephen L. Willis

I hereby certify that is correspondence and all marked attachm re being deposited with

Group Art Unit 2815

al Service as first-class the United State mail in an enve addressed to: Assistant Commissioner for ents, Washington, D.C.

Michael H. Tenholm, Reg. No. 37,743

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to the Restriction Requirement mailed October 10, 2001, the Applicant hereby elects Claim Group I (i.e., Claims 30-37) without traverse. By this paper, Applicant hereby cancels Claims 38-55, without prejudice. The Applicant believes that the application is now in condition for examination on the merits and requests the prompt examination of the same. Should there be any impediment to the prompt examination of this application that could be resolved by a telephone conference, the Examiner is respectfully requested to call the undersigned at the number shown below.

Appl. No. Filed

: 09/552,383 : April 19, 2000

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 10/7/1

By:

Michael HyTrenholm Registration No. 37,743 Attorney of Record 620 Newport Center Drive Sixteenth Floor Newport Beach, CA 92660 (909) 781-9231

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